



PATENT APPLICATION  
Docket No. 2522-022  
Client No. AW8030US/SY

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Seung-Jae Lee and Jin-Gi Hong  
Serial No. 10/626,096 Art Unit: 2818  
Filed: July 23, 2004 Examiner: not yet assigned  
For: GATE ELECTRODE OF A SEMICONDUCTOR DEVICE AND  
METHOD OF FORMING THE SAME  
Confirmation No. 9000

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

☒ under 37 CFR 1.97 (b); or  
(Within three months of filing national application; or date of entry of International application; or before mailing date of first office action on the merits; whichever occurs last)

☒ Applicant(s) submit herewith Form PTO 1449- Information Disclosure Citation together with copies of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

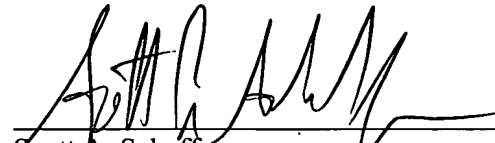
It is requested that the information disclosed herein be made of record in this application.

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703. A duplicate copy of this sheet is enclosed.

Customer No. 20575

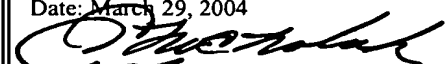
Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.

  
\_\_\_\_\_  
Scott A. Schaffer  
Reg. No. 38,610

MARGER JOHNSON & McCOLLOM, P.C.  
1030 SW Morrison Street  
Portland, OR 97205  
503-222-3613

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450  
Date: March 29, 2004

  
\_\_\_\_\_  
Adrienne Chocholak



PATENT APPLICATION  
Docket No. 2522-022  
Client No. AW8030US/SY

In re application of: Seung-Jae Lee and Jin-Gi Hong

Serial No. 10/626,096 Art Unit: 2818

Filed: July 23, 2004 Examiner: not yet assigned

For: GATE ELECTRODE OF A SEMICONDUCTOR DEVICE AND  
METHOD OF FORMING THE SAME

Confirmation No. 9000

**INFORMATION DISCLOSURE CITATION  
FORM PTO-1449 (Modified)**

**U.S. PATENT DOCUMENTS**

Exam <u>Init</u>	<u>Ref</u>	Document <u>Number</u>	Issue <u>Date</u>	<u>Name</u>	<u>Class</u>	Sub <u>Class</u>
_____	_____	5,877,074	5/2/1999	Jeng, et al.		

Examiner: \_\_\_\_\_

Date Considered: \_\_\_\_\_